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Single-Mask Fabrication Process for Linear and Angular Piezoresistive Accelerometers

Tech ID: 18804 / UC Case 2006-030-0

BACKGROUND

Piezoresistive accelerometers are traditionally fabricated by doping selected areas of wafer to achieve isolated pn-junctions. Often, two separate doping steps are employed to obtain both highly-doped conductors as well as lightly-doped piezoresistors. Once the piezoresistors and conductors have been defined, additional fabrication steps are required to etch the suspension system as well as the free-standing proof mass, which normally deflects in the out-of-plane direction.

Normally, four or more masks are used in the fabrication process making for complex and costly manufacturing. In addition, pn-junctions have high leakage currents at temperatures above 150OC, which is therefore the highest operational temperature of the sensors.

TECHNOLOGY DESCRIPTION

University researchers have developed a new method for fabricating piezoresistive accelerometers by utilizing silicon-on-insulator (SOI) wafers with a selected resistivity. The proposed fabrication process requires only one mask, thus reducing both the complexity and cost. Furthermore, the use of SOI wafers eliminates the need for a pn-junction normally required in piezoresistive sensors, allowing for less temperature-sensitive sensors.

APPLICATIONS

This fabrication method can be employed for sensors used for acceleration measurements, including but not limited to the following applications: airbag deployment systems, car crash testing, munitions testing, and inertial measurements.

PATENT STATUS

Country	Туре	Number	Dated	Case
United States Of America	Issued Patent	7,939,355	05/10/2011	2006-030

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OTHER INFORMATION

CATEGORIZED AS

» Sensors &Instrumentation» Other

» Physical Measurement

RELATED CASES 2006-030-0

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